



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....09/602,395  
Filing Date ..... June 22, 2000  
Inventor ..... John T. Moore  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Pham, Thanhha S.  
Attorney's Docket No. ....MI22-1384  
Title: Methods of Forming Oxide Regions Over Semiconductor Substrates

30/E  
9-28-03  
[Signature]

**RESPONSE TO MAY 12, 2003 OFFICE ACTION**

To: Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
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**AMENDMENTS**

**Introductory Comments**

In response to the Office Action dated May 12, 2003, applicant amends and remarks as follows.

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